



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kiyoshi Mita
Serial No. : 10/813,778
Filed : March 31, 2004
Title : METHOD FOR MANUFACTURING MOUNTING SUBSTRATE AND
METHOD FOR MANUFACTURING CIRCUIT DEVICE

Art Unit : 1753
Examiner : Luan V. Van

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF DECEMBER 28, 2005

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

March 27, 2006

Date of Deposit

Signature

Roselynn Scarfo

Roselynn Scarfo

Typed or Printed Name of Person Signing Certificate